Electronic Acknowledgement Receipt				
EFS ID:	1103128			
Application Number:	10568229			
Confirmation Number:	6289			
Title of Invention:	Group I-III-VI quaternary or higher alloy semiconductor films			
First Named Inventor:	Vivian Alberts			
Customer Number:	20995			
Filer:	Adeel S. Akhtar/Jonathan Pan (ASA)			
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Receipt Date:	06-JUL-2006			
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Time Stamp:	18:31:12			
Application Type:	U.S. National Stage under 35 USC 371			
International Application Number:				

## Payment information:

Submitted with Payment	no
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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		2006-07-06_Preliminary_Am endment_DMKISCH_003AP C.pdf		yes	3

	Multipart Description			
	Doc Desc	Start	End	
	Preliminary Amendment	1	1	
	Specification	2	2	
	Applicant Arguments/Remarks Made in an Amendment	3	3	
Warnings:		•		
Information				

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

Total Files Size (in bytes):

32757

## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.